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RESPONSE UNDER 37 C.F.R. § 1.116
EXPEDITED PROCEDURE
GROUP 1754
PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Docket No: Q79054

Masashi OTSUKI, et al.

Appln. No.: 10/758,130

Group Art Unit: 1754

Confirmation No.: 5017

Examiner: Ngoc Yen M. Nguyen

Filed: January 16, 2004

For: SILICON CARBIDE POWDER AND METHOD FOR PRODUCING THE SAME

RESPONSE UNDER 37 C.F.R. § 1.116

MAIL STOP AF

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

This is in response to the Office Action dated June 3, 2005. A Petition and payment for a two-month extension of time are attached, making this Response due on or before November 3, 2005.

Please consider the remarks as submitted herewith on the accompanying pages.